

Notice of References Cited

Application No.

10/003,219

Applicant(s)

A. Roesler

Examiner

L. Kiliman

Group Art Unit

1773

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U.S. PATENT DOCUMENTS

*	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS
A					
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FOREIGN PATENT DOCUMENTS

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N						
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NON-PATENT DOCUMENTS

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*U	R.J. Veitch, "Mimicking Very Thin Perforated Coatings," IEEE Transactions on Magnetics, Vol 36, Nos 2429-2431	8-00
*V	Veitch, "Improved Overwrite Performance," IEEE Transactions on Magnetics, Vol 35, Nos 2787-2789	8-88
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